



PATENT
Attorney Docket No. 403033/HOEGGER
Client Reference No. A 100 655 g

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

ENSINGER et al.

Application No. 10/814,590

Filed: April 1, 2004

For: RETAINING RING FOR HOLDING
SEMICONDUCTOR WAFERS IN A
CHEMICAL MECHANICAL POLISHING
APPARATUS

Art Unit: 3723

Examiner: Unassigned

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
220 20th Street S. Customer Window, Mail Stop Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

12/23/2004 NNGUYEN1 00000112 121216 10814590
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